

Graphene Measurement and Standards

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National Measurement System



Outline



NPL

- Graphene
- Graphene for Metrology
- Metrology for Graphene and other 2-D materials
- Measurement Techniques
- ISO and IEC Standards
- NIST



National Measurement System



About NPL ...

The UK's national standards laboratory

- Founded in 1900
- World leading National Measurement Institute
- 450+ specialists in **Measurement Science**
- State-of-the-art laboratory facilities
- The heart of the UK's National Measurement System to support business and society
- Experts in Knowledge Transfer
- GSA Lifetime Member
- Documentation available!





Graphene



Some properties:

- 2-D material
- High electron mobility
- Almost transparent
- High thermal conductivity
- Strongest material ever tested
- Bends and stretches

Possible commercial uses:

- Nanocomposites
- Transparent conductor
- High-frequency graphene electronics
- Sensors
- Energy Storage
- Flexible electronics



Graphene for Metrology



- NPL have demonstrated a graphene-based quantum Hall resistance standard for electrical metrology
 - Superior to those based on silicon field-effect transistors and group III-V semiconductors presently used
 - Much longer development history



Images courtesy of Prof. Alexander Tzalenchuk (A. Tzalenchuk, et al. *Nature Nanotech*, **5**, 186 (2010))

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Graphene Growth





- Scotch Tape
- SiC
- CVD
 - Transferrable
- Nanoribbons
- Liquid phase exfoliation



Novoselov *et al.* Nature, **490** 192 (2012) Pollard *et al.* J. Phys. Chem. C, **113** 16567 (2009)

Metrology for Graphene



- Develop and understand the application of analytical techniques
 - Graphene, similar 2-D materials and associated devices
 - Benefit from experience in other nanomaterials
 - Characterisation of the material properties
 - Defects, Contamination
- Combination of techniques



Measurement Capabilities







X-ray Photoelectron Spectroscopy (XPS)



Secondary Ion Mass Spectroscopy (SIMS)

Ellipsometry



Raman Spectroscopy (micro and tip-enhanced)



 X-ray Photoelectron Spectroscopy (XPS) of nitrogen-doped graphene on copper



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- Already highly experienced in difficulties of nanomaterials
- JWG 1: ISO TS 8004 series 'Graphene and other two dimensional materials' terminology standard
 - Nonmenclature NPL, 2013
- JWG2: Graphene Technical Report
 - How to perform measurements NIST, KRISS

- PT 62565-3-1 Graphene Material Specification (IEEE)
- PT 113-72 Graphene Material Specification: Nano-ink
- Nanomanufacturing Key control characteristics Electrical characterization of graphene
- Nanomanufacturing Key control characteristics The method to evaluate the number of layers of graphene
- Nanomanufacturing Key control characteristics The method to evaluate the defect level in the graphene layer

The NIST Approach to Graphene

Resistance and Optical Transparency Physical Standards

Documentary Standards

Measurement Science

National Institute of Standards and Technology

Graphene Research at NIST

And other carbon structures, i.e nanotubes, graphene oxide

The goal is to develop a measurement suite to enable the use of graphene in a broad range of innovative devices.

Novel Measurements

Device Performance

National Institute of Standards and Technology

Summary

- NPL strategic graphene-metrology initiative
 - Support research, innovation and commercialisation
- Graphene electrical metrology standard
- NPL world-class capability for electrical, structural and chemical characterisation measurement
- International standardisation of graphene as an enabler for industry
- NPL open to collaboration and input

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